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Title: Infrared-Spectroscopic Single-Shot Laser Mapping Ellipsometry: Proof of Concept for Fast Investigations of Structured Surfaces and Interactions in Organic Thin Films

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ACCEPTED MANUSCRIPT

- 1. An IR-spectroscopic mapping ellipsometer is developed based on a single-shot concept.
- 2. The ellipsometer is coupled to a broadband quantum cascade laser (1800-1540 cm-1).
- 3. Unprecedented time resolutions of 60 ms are reached.
- 4. Mapping and spectroscopic features are applied for thin-film characterization.

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